

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Sakae KOYATA et al., Group Art Unit : Not yet assigned
Appl. No. : Not yet assigned Examiner : Not yet assigned
Filed : Concurrently herewith Confirmation No. : Not yet assigned
For : METHOD FOR MANUFACTURING SINGLE-SIDE MIRROR SURFACE WAFER

AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop _____
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Sakae KOYATA et al.,


Bruce H. Bernstein
Reg. No. 29,027

Leslie J. Paperner
Reg. #33329

June 2, 2006
GREENBLUM & BERNSTEIN, P.L.C.
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191